PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT7162219

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date	
HONEYWELL INTERNATIONAL INC.	04/04/2021	

RECEIVING PARTY DATA

Name:	HONEYWELL HELIOS LLC
Street Address:	303 S TECHNOLOGY COURT
City:	BROOMFIELD
State/Country:	COLORADO
Postal Code:	80021

PROPERTY NUMBERS Total: 66

Property Type	Number
Application Number:	16856719
Application Number:	16709290
Application Number:	63072366
Application Number:	17444220
Application Number:	16704210
Application Number:	62845741
Application Number:	16717535
Application Number:	63037482
Application Number:	17316354
Application Number:	16717602
Application Number:	17302507
Application Number:	16716973
Application Number:	16705727
Application Number:	62896970
Application Number:	17008832
Application Number:	16872783
Application Number:	16683335
Application Number:	17644165
Application Number:	16872817
Application Number:	16702896

PATENT REEL: 058963 FRAME: 0120

507115379

Property Type	Number
Application Number:	63059320
Application Number:	17305201
Application Number:	63031410
Application Number:	17319511
Application Number:	63199279
Application Number:	17533587
Application Number:	63088064
Application Number:	17393011
Application Number:	63200263
Application Number:	17583308
Application Number:	15589370
Application Number:	15687688
Application Number:	15412857
Application Number:	15700937
Application Number:	15408170
Application Number:	15584456
Application Number:	15919959
Application Number:	15645324
Application Number:	13958302
Application Number:	16399568
Application Number:	14752368
Application Number:	16412278
Application Number:	16570726
Application Number:	16410694
Application Number:	16774886
Application Number:	14686576
Application Number:	13839923
Application Number:	14742346
Application Number:	14700312
Application Number:	14682810
Application Number:	14686553
Application Number:	14686481
Application Number:	15014709
Application Number:	14686501
Application Number:	14686592
Application Number:	15162027
Application Number:	15414295
Application Number:	14686524

Property Type	Number
Application Number:	14719587
Application Number:	15334067
Application Number:	14798941
Application Number:	17068639
Application Number:	16560917
Application Number:	16735438
Application Number:	17095856
Application Number:	16950607

CORRESPONDENCE DATA

Fax Number: (704)444-1111

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 7044441000

Email: patent-mail@alston.com

Correspondent Name: ALSTON & BIRD LLP/CHRISTOPHER TL DOUGLAS Address Line 1: BANK OF AMERICA PLAZA. 101 S. TRYON ST.

Address Line 2: SUITE 4000

Address Line 4: CHARLOTTE, NORTH CAROLINA 28280-4000

ATTORNEY DOCKET NUMBER:	066849/541301
NAME OF SUBMITTER:	CHRISTOPHER TL DOUGLAS
SIGNATURE:	/Christopher TL Douglas/
DATE SIGNED:	02/07/2022

Total Attachments: 10

source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page1.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page3.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page3.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page4.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page5.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page6.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page7.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page8.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page9.tif source=Project-Helios-Contribution_Agreement-Executed-Redacted-Apr-4-2021#page9.tif

CONTRIBUTION AGREEMENT

This CONTRIBUTION AGREEMENT (this "Agreement"), effective as of April 4, 2021, is entered into by and among HONEYWELL INTERNATIONAL INC., a Delaware corporation ("Transferor"), and HONEYWELL HELIOS LLC, a Delaware limited liability company ("Transferee" and, together with Transferors, the "Parties").

RECITALS

WHEREAS, Transferee is a direct subsidiary of Transferor.

WHEREAS, Transferor holds certain assets and liabilities relating to the Business.

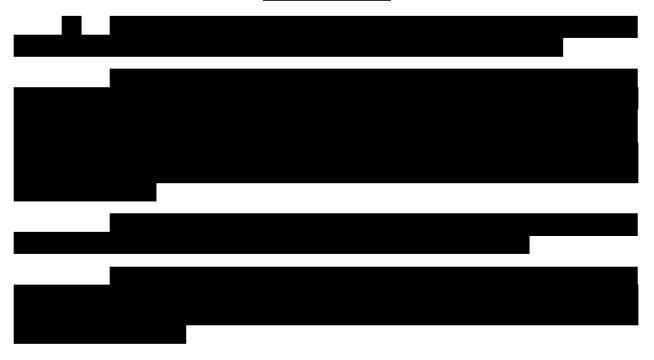
WHEREAS, Transferor has determined that it is in the best interest of itself and its Affiliates that Transferor undertake a corporate restructuring, pursuant to which assets and liabilities of the Business will be transferred from Transferor to Transferee.

WHEREAS, accordingly, Transferor desires to transfer, assign and contribute to Transferee, and Transferee desires to accept and assume from Transferor, certain assets and liabilities of the Transferor used in or relating to the Business, all as set forth in this Agreement (the "Contribution").

NOW, THEREFORE, in consideration of the representations, warranties, covenants and other agreements contained herein, and for other good and valuable consideration, the receipt and sufficiency of which are hereby acknowledged, the parties hereto hereby agree as follows:

ARTICLE I

CONTRIBUTION







1.2 <u>Transfer and Contribution of Assets</u>. Upon the terms and subject to the conditions set forth in this Agreement, effective as of the Closing Date, Transferor hereby transfers, conveys, assigns and delivers to Transferee, and Transferee hereby acquires and accepts from Transferor, all of Transferor's right, title and interest in, to and under the properties, rights, and assets that relate exclusively to the Business (but in all cases excluding the Retained Assets), in each case, as and to the extent such right, title and interest exists as of the Closing Date (such properties, rights, and assets are hereinafter collectively referred to as the "Contributed Assets"), including, but not limited to, the following Contributed Assets:



(d) all Intellectual Property Rights owned by Transferor as of the Closing Date that are exclusively used in or are exclusively related to the development, manufacture, marketing, use, or sale of the Business Services, including the Intellectual Property Rights identified on Schedule 1.2(d) (collectively, the "Transferred Intellectual Property");



IN WITNESS WHEREOF, the Parties hereto have caused this Agreement to be executed as of the date first written above by their respective officers thereunto duly authorized.

TRANSFEROR:

HONEYWELL INTERNATIONAL INC.

By Inne Madden

Name: Anne Madden

Title: Senior Vice President and General

Counsel

TRANSFEREE:

HONEYWELL HELIOS LLC

By:_____

Name: Anthony P. Uttley

Title: President

[Signature Page to Contribution Agreement]

IN WITNESS WHEREOF, the Parties hereto have caused this Agreement to be executed as of the date first written above by their respective officers thereunto duly authorized.

TRANSFEROR:

HONEYWELL INTERNATIONAL INC.

By:______Name: Anne Madden

Title: Senior Vice President and General

Counsel

TRANSFEREE:

HONEYWELL HELIOS LLC

Unthony P Uttley
Name: Anthony P. Uttley

Title: President

[Signature Page to Contribution Agreement]

Attachment 1.2(d)

[See attached.]

Patent: Patent ID	Filing Date	Application Number	Patent Number	Title	Prosecution Status	IP Right Status	Earliest Priority Date	Relationship to Parent
H0047661-US-4	5/8/2017	15/589,370	10,084,034	DEVICES, SYSTEMS, AND METHODS FOR ION TRAPPING	Issued	In Force	4/14/2015	Continuation
H0042745-US-2		15/687,688	10,119,913	DIE-INTEGRATED ASPHERIC MIRROR	Issued	In Force		Continuation
H0047621-US-2	1/23/2017	15/412,857	10,145,792	MULTI-CELL APPARATUS AND METHOD FOR SINGLE ION ADDRESSING	Issued	In Force	4/14/2015	Continuation
H0046598-US-3	9/11/2017	15/700,937	10,178,753	MICRO-STRUCTURED ATOMIC SOURCE SYSTEM	Issued	In Force	4/9/2015	Continuation
H0048584-US-2	1/17/2017	15/408,170	10,186,409	ION TRAPPING WITH INTEGRATED ELECTROMAGNETS	Issued	In Force	6/17/2015	Continuation
H0047622-US-2	5/2/2017	15/584,456	10,302,974	PREPARATION CELL SYSTEMS AND METHODS OF PREPARING A STATE OF LASER LIGHT	Issued	In Force	4/14/2015	Continuation
H0048586-US-4	3/13/2018	15/919,959	10,304,650	APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Issued	In Force	4/30/2015	Divisional
H0047729-US-2	7/10/2017	15/645,324	10,340,052	SINGLE CELL APPARATUS AND METHOD FOR SINGLE ION ADDRESSING ADAPTIVE OPTICAL ZOOM SYSTEMS AND	Issued	In Force	4/14/2015	Continuation
H0039790-US	8/2/2013	13/958,302	10,379,324	METHODS	Issued	In Force	8/2/2013	
H0048586-US-4-CON	4/30/2019	16/399,568	10,546,734	APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS APPARATUS AND METHOD FOR TRAPPING	Issued	In Force	4/30/2015	Continuation
H0048582-US	6/26/2015	14/752,368	10,553,414	MULTIPLE IONS GENERATED FROM MULTIPLE SOURCES	Issued	In Force	6/26/2015	
H214709-US2	12/17/2019	16/717,535	10,733,524	QUANTUM D-STATE AC-STARK SHIFT GATE	Issued	In Force	5/9/2019	From Provisional
H211337-US	5/14/2019	16/412,278	10,804,871	CRYOGENIC RADIO-FREQUENCEY RESONATOR FOR SURFACE ION TRAPS	Issued	In Force	5/14/2019	
H0049384-US		16/570,726	10,840,078	ENCLOSURE FOR ION TRAPPING DEVICE	Issued	In Force	9/13/2019	
H209238-US		16/410,694	10,867,855	THROUGH SILICON VIA FABRICATION APPARATUSES, SYSTEMS, AND METHODS	Issued	In Force	5/13/2019	
H0048586-US-4-CON2	1/28/2020	16/774,886	10,950,408	FOR ION TRAPS BICHROMATIC LASER FOR QUANTUM	Issued	In Force	4/30/2015	Continuation
H218167-US	12/4/2019	16/702,896	10,951,002	COMPUTING APPLICATIONS	Issued	In Force	12/4/2019	
H0047661-GB	11/19/2015	15195480.7	3050843	DEVICES, SYSTEMS, AND METHODS FOR ION TRAPPING	Issued	In Force	1/30/2015	National/Regional Phase
H0048586-GB	2/17/2016	16156215.2	3088354	APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Issued	In Force	4/30/2015	National/Regional Phase
H0048586-AT	2/17/2016	16156215.2	3088354	APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Issued	In Force	4/30/2015	National/Regional Phase
H0047621-GB	2/8/2016	16154696.5	3088869	MULTI-CELL APPARATUS AND METHOD FOR SINGLE ION ADDRESSING	Issued	In Force	4/14/2015	National/Regional Phase
H0047729-GB		16163767.3	3091352	SINGLE CELL APPARATUS AND METHOD FOR SINGLE ION ADDRESSING	Issued	In Force		National/Regional Phase
H0048581-GB		16159281.1	3096327	ION TRAP WITH VARIABLE PITCH ELECTRODES	Issued	In Force		National/Regional Phase
				ION TRAPPING WITH INTEGRATED				
H0048584-AT		16164338.2	3106427	ELECTROMAGNETS ION TRAPPING WITH INTEGRATED	Issued	In Force		National/Regional Phase
H0048584-DE		16164338.2	3106427	ELECTROMAGNETS ION TRAPPING WITH INTEGRATED	Issued	In Force		National/Regional Phase
H0048584-GB H0048582-GB		16164338.2 16165878.6	3106427 3109802	ELECTROMAGNETS TRAPPING MULTIPLE IONS DEVICES, SYSTEMS, AND METHODS FOR ION	Issued Issued	In Force In Force		National/Regional Phase National/Regional Phase
H0047661-DE	11/19/2015	EP3050843	602015005577.2	TRAPPING MULTI-CELL APPARATUS AND METHOD FOR	Issued	In Force	1/30/2015	National/Regional Phase
H0047621-DE	2/8/2016	EP3088869	602016005236.9	SINGLE ION ADDRESSING	Issued	In Force	4/14/2015	National/Regional Phase
H0047729-DE	4/4/2016	EP3091352	602016005263.6	SINGLE CELL APPARATUS AND METHOD FOR SINGLE ION ADDRESSING	Issued	In Force	4/14/2015	National/Regional Phase
H0048581-DE	3/8/2016	16159281.1	602016013440.3	ION TRAP WITH VARIABLE PITCH ELECTRODES	Issued	In Force	5/22/2015	National/Regional Phase
H0047661-US-2	4/14/2015	14/686,576	9,287,348	DEVICES, SYSTEMS, AND METHODS FOR ION TRAPPING	Issued	In Force	4/14/2015	Claims Priority
H0037719-US	3/15/2013	13/839,923	9,371,222	MICROSTRUCTURE PLATING SYSTEMS AND METHODS	Issued	In Force	3/15/2013	
H0048584-US	6/17/2015	14/742,346	9,548,191	ION TRAPPING WITH INTEGRATED ELECTROMAGNETS	Issued	In Force	6/17/2015	
H0048586-US	4/30/2015	14/700,312	9,558,908	APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Issued	In Force	4/30/2015	
H0046598-US		14/682,810	9,585,237	MICRO-STRUCTURED ATOMIC SOURCE SYSTEM	Issued	In Force	4/9/2015	
H0047621-US		14/686,553	9,588,047	MULTI-CELL APPARATUS AND METHOD FOR SINGLE ION ADDRESSING				
H0047621-05	4/14/2015	14/686,553	9,588,047		Issued	In Force	4/14/2015	
H0047622-US	4/14/2015	14/686,481	9,645,417	PREPARATION CELL SYSTEMS AND METHODS OF A PREPARING A STATE OF LASER LIGHT DEVICES, SYSTEMS, AND METHODS FOR ION	Issued	In Force	4/14/2015	
H0047661-US-3		15/014,709	9,647,055	TRAPPING	Issued	In Force		Continuation
H0047669-US	4/14/2015	14/686,501	9,658,404	OPTICAL BENCH SINGLE CELL APPARATUS AND METHOD FOR	Issued	In Force	4/14/2015	
H0047729-US H0037719-US-2		14/686,592 15/162,027	9,715,950 9,758,364	SINGLE ION ADDRESSING MICROSTRUCTURE PLATING SYSTEMS MICRO-STRUCTURED ATOMIC SOURCE	Issued Issued	In Force In Force	4/14/2015 3/15/2013	Divisional
H0046598-US-2	1/24/2017	15/414,295	9,788,407	SYSTEM	Issued	In Force	4/9/2015	Continuation
H0042745-US		14/686,524	9,791,370	DIE-INTEGRATED ASPHERIC MIRROR ION TRAP WITH VARIABLE PITCH	Issued	In Force	4/14/2015	
H0048581-US	5/22/2015	14/719,587	9,837,258	ELECTRODES	Issued	In Force	5/22/2015	
H0048586-US-2	10/25/2016	15/334,067	9,916,957	APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Issued	In Force	4/30/2015	Divisional

HUU47668-US	//14/2015 14//98,941	9,989,730	ALIGNMENT OF AN OPTICAL COMPONENT	Issued	In Force	//14/2015
			APPARATUSES, SYSTEMS, AND METHODS			
H0048586-DE	2/17/2016 EP3088354	DE602016000713.4	FOR ION TRAPS	Issued	In Force	4/30/2015 National/Regional Phase
H0048582-DE	4/18/2016 EP3109802	DE602016003477.8	TRAPPING MULTIPLE IONS	Issued	In Force	6/26/2015 National/Regional Phase

Pate H214156 H216746 H217046	6-US	Filing Date Application Number 12/5/2019 16/704,210 12/17/2019 16/716,973 12/6/2019 16/705,727	Patent Number	Title SUPERCONDUCTING SHIELD FOR CRYOGENIC CHAMBER QUANTUM COMPUTER PHASE TRACKING AND CORRECTION HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Prosecution Status Filed Filed Filed	IP Right Status Pending Pending Pending	Earliest Priority Date 12/5/2019 12/17/2019 12/6/2019	Relationship to Parent
HZ17040	0-03	12/6/2013 16/703,727		HOLOGRAPHIC QUANTOW DTNAMICS SIMOLATION	riieu	rending	12/0/2019	
H211424	4-US	12/10/2019 16/709,290		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS	Filed	Pending	12/10/2019	
H216416		12/17/2019 16/717,602		APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Filed	Pending	12/17/2019	
H217499		11/14/2019 16/683,335		INTEGRATED ACTIVE/PASSIVE VISIBLE/UV MODULATOR	Filed	Pending	11/14/2019	
H207325	5-US	4/23/2020 16/856,719		TESTING ENVIRONMENT FOR CRYOGENIC CHAMBER	Filed	Pending	4/23/2020	
H217266	6.118	5/12/2020 16/872,783		DYNAMIC NOISE SHAPING FILTERS AND CORRESPONDING METHODS	Filed	Pending	5/12/2020	
11217200	0-03	3/12/2020 10/8/2,/63		DIVAMIC NOISE SHAFING HETERS AND CONNESS ONDING METHODS	neu	rending	3/12/2020	
H218255	5-US	7/31/2020 63/059,320		ION TRAP APPARATUS WITH INTEGRATED SWITCHING APPARATUS APPARATUSES, COMPUTER-IMPLEMENTED METHODS, AND COMPUTER PROGRAM PRODUCTS FOR INSTRUCTION COMPILATION FOR AT LEAST	Filed	Pending	7/31/2020	
H218689	0.116	F (20/2020 /2/021 410		ONE TIME SLICE IN A ONE-DIMENSIONAL QUANTUM COMPUTING ENVIRONMENT	r:i_d	Ddi	E /20 /2020	
H209238		5/28/2020 63/031,410 3/11/2020 3075107		THROUGH SILICON VIA FABRICATION	Filed Filed	Pending Pending	5/28/2020 5/13/2019 C	laime Briority
H214709		5/4/2020 3080280		QUANTUM COMPUTING PHASE GATE	Filed	Pending		laims Priority
H214709		4/27/2020 2020-077897		QUANTUM D-STATE AC-STARK SHIFT GATE	Filed	Pending		laims Priority
H214709	9-SG	4/13/2020 10202003328X		QUANTUM COMPUTING PHASE GATE	Filed	Pending		laims Priority
H219811	1.115	2/3/2021 63/145,039		NOISE MITIGATION CIRCUITRY FOR QUANTUM COMPUTERS AND CORRESPONDING METHODS	Filed	Pending	2/3/2021	
HZ1361.	1-03	2/3/2021 03/143,033		PREPARATION CELL SYSTEMS AND METHODS OF A PREPARING A STATE	riieu	rending	2/3/2021	
H217499	5-EP	10/16/2020 20202442.8		OF LASER LIGHT	Filed	Pending	11/14/2019 C	aims Priority
H213810	0-US	8/31/2020 63/072,366		LOW TEMPERATURE LOW-ABUNDANCE ATOMIC OBJECT DISPENSER	Filed	Pending	8/31/2020	
H220658	8-US	10/6/2020 63/088,064		DECREASED CROSSTALK ATOMIC OBJECT DETECTION	Filed	Pending	10/6/2020	
H21133	7-US-CON	10/12/2020 17/068,639		CRYOGENIC RADIO-FREQUENCEY RESONATOR FOR SURFACE ION TRAPS	Filed	Pending	5/14/2019 C	ontinuation
H216416		11/25/2020 2020277183		APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Filed	Pending	12/17/2019 C	
H216416		12/8/2020 3101927		APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Filed	Pending	12/17/2019 C	
H216416	6-CN	12/2/2020 202011394426.1		APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Filed	Pending	12/17/2019 C	laims Priority
H216416		12/2/2020 20211376.7		APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Filed	Pending	12/17/2019 C	
H216416		11/26/2020 279014		APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Filed	Pending	12/17/2019 C	
H216416		12/8/2020 2020-203581		APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Filed	Pending	12/17/2019 C	
H216416		12/8/2020 10-2020-0170303 11/25/2020 10202011725Q		APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS APPARATUSES, SYSTEMS, AND METHODS FOR ION TRAPS	Filed Filed	Pending Pending	12/17/2019 C 12/17/2019 C	
H218167		11/12/2020 2020267250		BICHROMATIC LASER FOR QUANTUM COMPUTING APPLICATIONS	Filed	Pending	12/4/2019 C	·
H218167		11/19/2020 3100048		BICHROMATIC LASER FOR QUANTUM COMPUTING APPLICATIONS	Filed	Pending	12/4/2019 C	
H21816		12/2/2020 202011393705.6		BICHROMATIC LASER FOR QUANTUM COMPUTING APPLICATIONS	Filed	Pending	12/4/2019 C	
H218167		11/20/2020 20209083.3		BICHROMATIC LASER FOR QUANTUM COMPUTING APPLICATIONS	Filed	Pending	12/4/2019 C	
H218167		11/16/2020 278737		BICHROMATIC LASER FOR QUANTUM COMPUTING APPLICATIONS	Filed	Pending	12/4/2019 C	
H21816		12/2/2020 2020-200097		BICHROMATIC LASER FOR QUANTUM COMPUTING APPLICATIONS	Filed	Pending	12/4/2019 C	
H218167		12/3/2020 10-2020-0167451		BICHROMATIC LASER FOR QUANTUM COMPUTING APPLICATIONS	Filed	Pending	12/4/2019 C	
H218167		11/12/2020 10202011234W 11/18/2020 2020270516		BICHROMATIC LASER FOR QUANTUM COMPUTING APPLICATIONS HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Filed Filed	Pending Pending	12/4/2019 C 12/6/2019 C	
H217046		11/26/2020 3100864		HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Filed	Pending	12/6/2019 C	
H217046		12/2/2020 202011396640.0		HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Filed	Pending	12/6/2019 C	
H217046		11/24/2020 20209625.1		HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Filed	Pending	12/6/2019 C	
H217046		11/18/2020 278800		HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Filed	Pending	12/6/2019 C	
H217046		12/4/2020 2020-201918		HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Filed	Pending	12/6/2019 C	
H217046		12/2/2020 10-2020-0166615		HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Filed	Pending	12/6/2019 C	
H217046		11/18/2020 10202011484P 11/26/2020 202014051600		HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION HOLOGRAPHIC QUANTUM DYNAMICS SIMULATION	Filed	Pending	12/6/2019 C	
H217046		11/26/2020 202014051600		QUANTUM COMPUTER PHASE TRACKING AND CORRECTION	Filed Filed	Pending Pending	12/6/2019 C 12/17/2019 C	
H216746		12/8/2020 3101918		QUANTUM COMPUTER PHASE TRACKING AND CORRECTION	Filed	Pending	12/17/2019 C	
H216746		12/3/2020 202011395617.X		QUANTUM COMPUTER PHASE TRACKING AND CORRECTION	Filed	Pending	12/17/2019 C	
H216746		12/2/2020 20211374.2		QUANTUM COMPUTER PHASE TRACKING AND CORRECTION	Filed	Pending	12/17/2019 C	
H216746	6-IL	11/26/2020 279016		QUANTUM COMPUTER PHASE TRACKING AND CORRECTION	Filed	Pending	12/17/2019 C	
H216746		12/11/2020 2020-205690		QUANTUM COMPUTER PHASE TRACKING AND CORRECTION	Filed	Pending	12/17/2019 C	laims Priority
H216746		12/3/2020 10-2020-0167452		QUANTUM COMPUTER PHASE TRACKING AND CORRECTION	Filed	Pending	12/17/2019 C	
H216746		11/25/2020 10202011728P		QUANTUM COMPUTER PHASE TRACKING AND CORRECTION	Filed	Pending	12/17/2019 C	
H211424		11/20/2020 2020273358		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS		Pending	12/10/2019 C	
H211424		12/1/2020 3101287		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS		Pending	12/10/2019 C	
H211424		12/1/2020 202011389578.2		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS		Pending	12/10/2019 C	
H211424		11/25/2020 20209916.4		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS		Pending	12/10/2019 C	
H211424		11/22/2020 278871		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS		Pending	12/10/2019 C	aims Priority
H211424		12/8/2020 2020-203332		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS		Pending	12/10/2019 C	laims Priority
H211424		12/10/2020 10-2020-0171857		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS		Pending	12/10/2019 C	
H211424		11/20/2020 10202011557Y		SUPPRESSING/TRANSFORMING LEAKAGE ERRORS IN HYPERFINE QUBITS		Pending	12/10/2019 C	laims Priority
H221995		2/25/2021 63/200,263		QUBIT READING PROCEDURE INCLUDING COHERENT SHELVING	Filed	Pending	2/25/2021	Inime Briority
H207325 H207325		2/23/2021 202110202090.2 2/23/2021 21158832.2		TESTING ENVIRONMENT FOR CRYOGENIC CHAMBER TESTING ENVIRONMENT FOR CRYOGENIC CHAMBER	Filed Filed	Pending Pending	4/23/2020 C 4/23/2020 C	
1120/32	<i>y</i> =r	CI CALCACT ST130035'S		DETERMINISTIC RESHAPING AND/OR REORDERING OF GROUPS OF ATOMIC OBJECTS WITHIN AN ATOMIC OBJECT CONFINEMENT	i neu	enuing	4/23/2020 C	cams ritority
H218083	3-US	5/12/2020 16/872,817		APPARATUS	Filed	Pending	5/12/2020	
H216102		6/10/2020 63/037,482		BEAM DELIVERY SYSTEM	Filed	Pending	6/10/2020	
H209238		3/13/2020 2020-044294		THROUGH SILICON VIA FABRICATION	Filed	Pending	5/13/2019 C	aims Priority
H211337	7-CA	5/11/2020 3080777		CRYOGENIC RADIO-FREQUENCEY RESONATOR FOR SURFACE ION TRAPS	Filed	Pending	5/14/2019 C	aims Priority
H211337	7-JP	5/13/2020 2020-084598		CRYOGENIC RADIO-FREQUENCEY RESONATOR FOR SURFACE ION TRAPS	Filed	Pending	5/14/2019 C	aims Priority

H211337-SG	5/5/2020 10202004132V	CRYOGENIC RADIO-FREQUENCEY RESONATOR FOR SURFACE ION TRAPS APPARATUSES, SYSTEMS, AND METHODS FOR ELLIPTICAL ATOMIC	Filed	Pending	5/14/2019 Claims Priority
H219941-US	12/17/2020 63/199,279	OBJECT TRAPS	Filed	Pending	12/17/2020
H208126-US	9/4/2019 16/560,917	CABLE MANAGEMENT FOR CRYOGENIC SYSTEM	Published	Pending	9/4/2019
H214413-US2	1/6/2020 16/735,438	DETECTION SCHEME	Published	Pending	2/27/2019 From Provisional
H209238-EP	3/6/2020 20161664.6	THROUGH SILICON VIA FABRICATION	Published	Pending	5/13/2019 Claims Priority
H214709-EP	5/6/2020 20173349.0	QUANTUM D-STATE AC-STARK SHIFT GATE	Published	Pending	5/9/2019 Claims Priority
H214709-CN	5/6/2020 202010375430.7	QUANTUM D-STATE AC-STARK SHIFT GATE	Published	Pending	5/9/2019 Claims Priority
H217248-US2	9/1/2020 17/008,832	COMPACT LASER DELIVERY TO ATOMIC SYSTEMS	Published	Pending	9/6/2019 From Provisional
H209238-US-CON	11/12/2020 17/095,856	THROUGH SILICON VIA FABRICATION	Published	Pending	5/13/2019 Continuation
H0049384-US-CIP	11/17/2020 16/950,607	ENCLOSURE FOR ION TRAPPING DEVICE	Published	Pending	9/13/2019 Continuation-in-part
H0042745-EP	2/8/2016 16154682.5	DIE-INTEGRATED ASPHERIC MIRROR	Published	Pending	4/14/2015 Claims Priority
		PREPARATION CELL SYSTEMS AND METHODS OF PREPARING A STATE OF			
H0047622-EP	2/8/2016 16154710.4	LASER LIGHT	Published	Pending	4/14/2015 Claims Priority
H0047669-EP	2/8/2016 16154735.1	OPTICAL BENCH	Published	Pending	4/14/2015 Claims Priority
H214413-EP	2/24/2020 20159165.8	DETECTION SCHEME	Published	Pending	2/27/2019 Claims Priority
H209238-CN	3/12/2020 202010170957.6	THROUGH SILICON VIA FABRICATION	Published	Pending	5/13/2019 Claims Priority
H211337-CN	5/14/2020 202010407779.4	CRYOGENIC RADIO-FREQUENCEY RESONATOR FOR SURFACE ION TRAPS	Published	Pending	5/14/2019 Claims Priority
H211337-EP	5/12/2020 20174220.2	CRYOGENIC RADIO-FREQUENCEY RESONATOR FOR SURFACE ION TRAPS	Published	Pending	5/14/2019 Claims Priority
H0049384-EP	7/8/2020 20184829.8	ENCLOSURE FOR ION TRAPPING DEVICE	Published	Pending	9/13/2019 Claims Priority
H217248-EP	9/2/2020 20194204.2	COMPACT LASER DELIVERY TO ATOMIC SYSTEMS	Published	Pending	9/6/2019 Claims Priority

RECORDED: 02/07/2022